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PATENT

Attorney Docket No. 10113671



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Meng-Hung CHEN

Filed: 1/21/2004

Appl. No.: 10/761,702

Examiner: Warren, Matthew E

Conf. No.: 3361

Art Unit: 2815

Title: BIT LINE CONTACT STRUCTURE AND FABRICATION METHOD  
THEREOF

Date: March 8, 2005

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §1.56, the materials listed on the attached form PTO-1449 are being brought to the attention of the Examiner for consideration in connection with the examination of the above-identified patent application.

The information disclosure statement submitted herewith is being filed within three months of the filing date of the above-identified application or date of entry into the national stage of an international application related thereto, or, to the best of applicant's knowledge, before the mailing date of the first Office Action on the merits, whichever occurs last.

Should the Office mail an Office Action on the merits before or on the same day as the mailing

of this IDS, Applicant furthermore certifies under 37 C.F.R. 1.97(e) that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement. A copy of the foreign office action dated January 13, 2005 is enclosed. . In addition, a copy of each non-U.S. patent or patent application publication is enclosed.

The filing of this information disclosure statement shall not be construed to be a representation that a search has been conducted, nor shall it be construed as an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

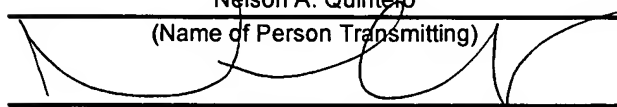
It is respectfully requested that the Examiner return a copy of the attached form PTO-1449 with initials or other appropriate marks indicating consideration of the cited materials.

Please charge any required additional fee or underpayment of fee to deposit account No.

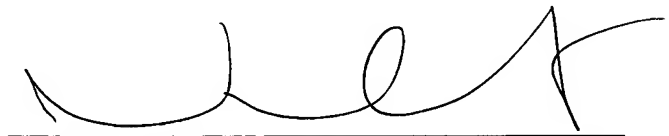
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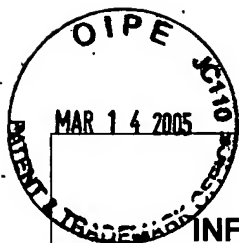
Nelson A. Quintero  
(Name of Person Transmitting)  
  
(Signature)  
March 8, 2005  
(Date)

Respectfully submitted,



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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT***(use as many sheets as necessary)***Complete if Known**

Sheet	1	of	1	Application Number	10761,702
				Filing Date	January 21, 2004
				First Named Inventor	Meng-Hung CHEN
				Art Unit	2815
				Examiner Name	Warren, Matthew E
				Attorney Docket Number	10113671

**U.S. PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number (Number – kind code)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Passages or Relevant Figures Appear
	A1	US-6,006,569	05-23-2000		
	A2				
	A3				
	A4				
	A5				
	A6				
	A7				

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number (Number – kind code)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Passages or Relevant Figures Appear	T
	B1					
	B2					

**OTHER ART**

Examiner Initials	Cite No.	Include name of author (in CAPS), title of article" (when appropriate), title of the item (book, magazine, symposium, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T
	C1	HONG XIAO, "Introduction to semiconductor manufacturing technology", 2001, pages 568-569, Prentice Hall Inc., USA	
	C2	STANLEY WOLF, "Silicon Processing for the VLSI Era: Process Integration, Vol. 2", 1990, pages 214-217, Lattice Press, USA	
	C3		
	C4		
	C5		

Form PTO-1449 (modified)

(v08/25/2002)

P109580NAQ

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.

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